

AF/1756
JFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/054,259 Confirmation No. 7049
Applicant : Ronald M. Kubacki
Filed : January 22, 2002
TC/A.U. : Art Unit 1756
Examiner : Kathleen DUDA
Docket No. : 02-103
Customer No. : 24026
Title: : Capacitor with Plasma Deposited Dielectric

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner for Patents:

This amendment is in response to the FINAL Office action dated May 25, 2004, and is being filed within two months of the mailing date of the final office action.

Amendments to the Claims are reflected in the listing of claims, which begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that this paper, along with any paper referred to as being attached or enclosed, is being deposited with the United States Postal Service on the date indicated below, with sufficient postage, as first class mail, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature

Printed Name Philip O. Post

Date JUNE 4, 2004